

2882



PATENT

#16
D. Scott
6/19/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Allan Rosencwaig et al.

Application No.: 09/629,407

Filed: August 1, 2000

For: MEASUREMENT OF THIN FILMS
AND BARRIER LAYERS ON
PATTERNED WAFERS WITH X-RAY
REFLECTOMETRY

Confirmation No.:

Group Art Unit: 2876

Examiner: H.K. Song

SUBMISSION OF FORMAL DRAWINGS

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CERTIFICATE OF MAILING

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STALLMAN & POLLOCK LLP

Dated: 02/18/2003 By: Georgia K. Stith
Georgia K. Stith

Sir:

Enclosed are three (3) sheets of formal drawings for filing in the above-referenced
application.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: February 18, 2003

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